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Docket No.: 0756-2332

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of

Takeshi FUKADA, et al

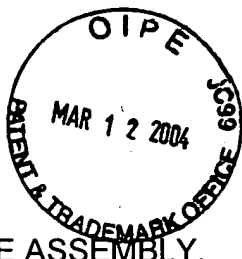
Serial No. 09/904,906

Filed: 07/16/01

For: GLASS SUBSTRATE ASSEMBLY,

SEMICONDUCTOR DEVICE AND METHOD

OF HEAT-TREATING GLASS SUBSTRATE



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Group Art Unit: 2825

) Examiner: L. Malsawma

**REQUEST FOR ACKNOWLEDGMENT OF
INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents

P. O. Box 1450

Alexandria VA 22313-1450

Sir:

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, P. O. Box 1450, Alexandria VA, 22313-1450, on March 10, 2004

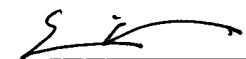
Erin A. Davis

Applicants acknowledge with appreciation the Notice of Allowability and Issue Fee Due form mailed March 3, 2004.

The Notice of Allowability did not, however, include an initialed Form PTO-1449 acknowledging the Information Disclosure Statement filed December 9, 2003. Therefore, it is respectfully requested that the Examiner evidence consideration of the references cited in the IDS of December 9, 2003 by providing a copy of the initialed Form PTO-1449.

If a conference would be beneficial in expediting the prosecution of the instant application, the Examiner is invited to telephone the undersigned to arrange such a conference.

Respectfully submitted,


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